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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	:	
Ho Yup KWON	:	Confirmation No.: 6119
Serial No. 10/814,289	:	Art Unit: 2814
Filed: April 1, 2004	:	Examiner: (not yet assigned)
For: SEMICONDUCTOR DEVICE, AND	:	Atty Docket: P68464US1
METHOD FOR MANUFACTURING THE	:	
SAME	:	

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith on form PTO-1449 is a listing of a document known to Applicant and/or his attorney in compliance with the requirements of 37 CFR 1.56. A copy of the document is also being submitted. An English language abstract is provided for document AL in place of a translation. No translation is provided for document AL, as no translation is within the possession, custody or control of, or are readily available to any individual designated in 37 CFR 1.56(c). See MPEP 609A(2).

Since the Information Disclosure Statement is filed before the issuance of the first Office Action on the merits or within three months of filing, no fee is required. The Commissioner is

hereby authorized to charge fees under 37 CFR § 1.17 which may be required for consideration of this paper; or credit any overpayment to Deposit Account No. 06-1358.

In accordance with 37 CFR § 1.97(g) and (h), the filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made, or as an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 CFR § 1.56(b).

Applicant does not waive any rights to appropriate action to establish patentability over the listed document should it be applied as references against the claims of the present application.

RELEVANCE OF THE DOCUMENT

Document AL was cited in a Notice of Rejection issued in connection with the Korean patent application corresponding to the present application. A copy of the Notice of Rejection and a translation thereof are also submitted herewith.

CONCLUSION

It is respectfully requested that the Examiner initial and return a copy of the enclosed Form PTO-1449, and to similarly indicate in the official file wrapper of this patent application that the listed document has been considered.

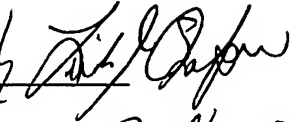
If the Examiner has any questions or wishes to discuss this application, the Examiner is invited to telephone the undersigned representative at the number set forth below.

Respectfully submitted,

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Form PTO-1449

Information Disclosure Citation

Attorney Docket
P68464US1Application No.
10/814,289

Applicant

Ho Yup KWON

Filing Date
April 1, 2004Group Art Unit
2814

U.S. Patent Documents

Examiner Initial		Patent Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents

		Document Number	Date	Country	Class	Sub-Class	Translation
	AL	JP2000-58818	02/2000	Japan			Abstract
	AM						Yes No
	AN						Yes No
	AO						Yes No
	AP						Yes No

Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)

	AR	
	AS	
	AT	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.